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Stylesheet Version v1.1.0

Title of Invention	METHOD OF FABRICATING POLY-CRYSTAL ITO FILM AND POLYCRYSTAL ITO ELECTRODE	
Application Number :		
Date :		
First Named Applicant:	Mr. Fang-An Shu	
Confirmation Number:		
Attorney Docket Number:	14150-US-PA	
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Submitted By:		Elec. Sign.
Dr. Belinda Lee Registered Number: 46,863		/Belinda Lee/ Sign. Capacity Agent

Documents being submitted:	Files
us-assignment	14150-usassn.xml us-assignment.xsl us-assignment.dtd 14150ASSIGNMENT1.tif 14150ASSIGNMENT2.tif
us-request	14150-usrequ.xml us-request.dtd us-request.xsl
us-fee-sheet	14150-usfees.xml us-fee-sheet.xsl us-fee-sheet.dtd
us-ids	14150-usidst.xml us-ids.dtd us-ids.xsl
application-body	14150usf.xml application-body.dtd Image1.tif Image2.tif Image3.tif Image4.tif Image5.tif Image6.tif Image7.tif Image8.tif isoamsa.ent isoamsb.ent isoamsc.ent isoamsn.ent isoamso.ent isoamsr.ent isobox.ent isocyr1.ent isocyr2.ent isodia.ent isogr1.ent isogr2.ent isogr3.ent isogr4.ent isolat1.ent isolat2.ent isomfrk.ent isomopf.ent isomscr.ent isonum.ent isopub.ent isotech.ent mathml2.dtd mathml2-qname-1.mod mmlalias.ent

	mmlextra.ent
	soextblx.dtd
	us-application-body.xsl
	wipo.ent
application-body-pdf-wrap	14150usf-pdf-wrap.xml
abstract-pdf	14150usf-abst.pdf
claims-pdf	14150usf-clms.pdf
description-pdf	14150usf-desc.pdf
drawings-pdf	14150usf-draw.pdf
us-declaration	14150DECLARATION1.tif
us-declaration	14150DECLARATION2.tif
Comments	
<p>Please be kindly advised that the indicated fee of this EFS application is intended to be paid by credit card. However, in the event that the payment through credit card is unsuccessful, the Commissioner is authorized to charge the required fee in connection with this application to Deposit Account No. 50-2620(Order No. 14150-US-PA). Deposit Account Name: Jianq Chyun Intellectual Property Office, Authorized User Name: Belinda Lee, E-mail: Belinda@jcipgroup.com.tw; usa@jcipgroup.com.tw</p>	